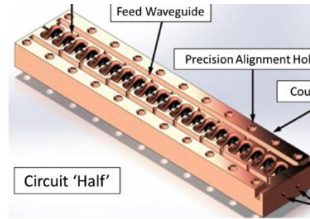
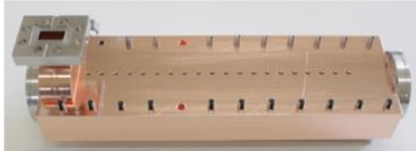


Dielectric Accelerators in Cryogenic Temperature

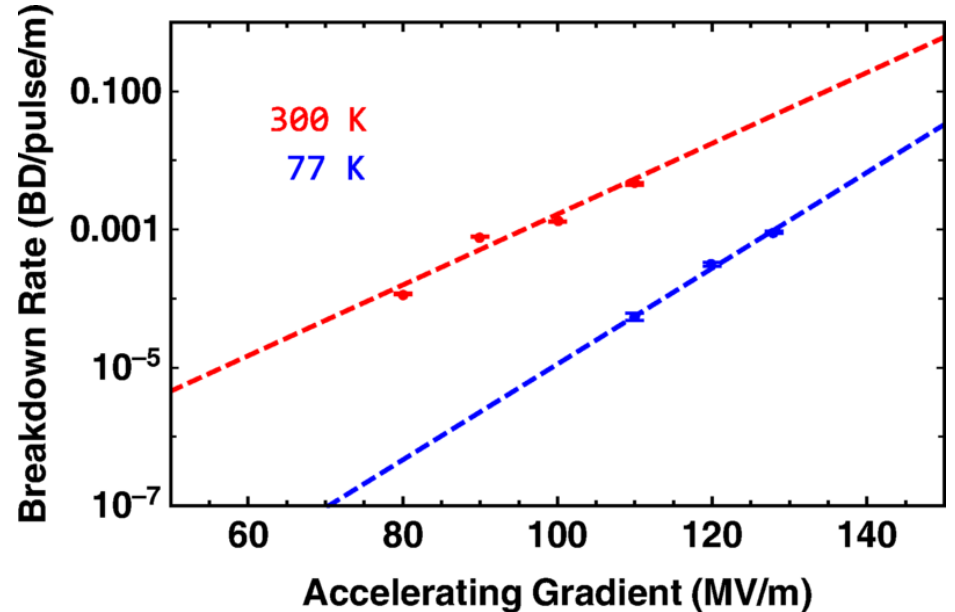
Chunguang Jing
Euclid Techlabs (Beamlabs), LLC

Motivation (I)---Cold Copper Structure

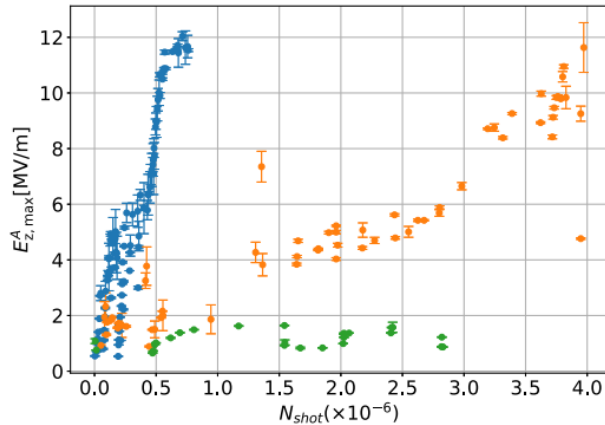
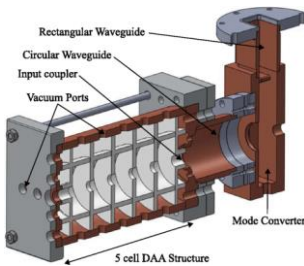
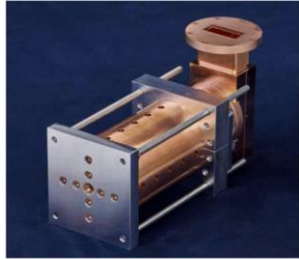


Parameter	300 K	77 K
Frequency (GHz)	11.402	11.438
Q_0	10000	22500
Q_{ext}	10000	10000
Shunt impedance ($M\Omega/m$)	155	349
Peak surface E (MV/m)	250	250
Peak surface H (MA/m)	0.575	0.575
Steady state rf power (MW)	17	9
Iris diameter (mm)	2.6	2.6
Length (cm)	26	26

- Sami Tantawi, *et al*, *Phys. Rev. Accel. Beams* **23**, 092001 (2020)
- Mamdouh Nasr, *et al*, *Phys. Rev. Accel. Beams* **24**, 093201 (2021)



Motivation (II)---Dielectric Assisted structure in cold



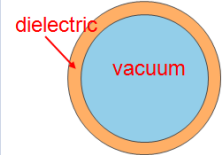
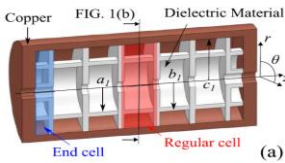
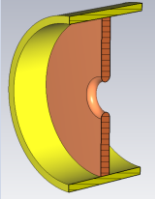
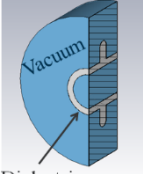
Parameter	Five-cell DAA structure
Dielectric material	Magnesia
ϵ_r	9.64
$\tan \delta$	6.0×10^{-6}
Accelerator type	Standing wave type
Accelerating mode	TM ₀₂ - π mode
Operation frequency	5.712 GHz
Number of accelerating cells	5
Total cavity length	157.5 mm
Q_0	126,400
Z_{sh}	630 M Ω /m
E_{max}/E_0	2.92
H_{max}/E_0	2.74 mA/V

- Daisuke Satoh, et al, Phys. Rev. Accel. Beams 20, 091302 (2017)
- Daisuke Satoh, et al, Nucl. Inst. and Meth. Phys. Res. B 459 (2019) 148–152.
- Shingo Mori, et al, Phys. Rev. Accel. Beams 24, 022001 (2021)

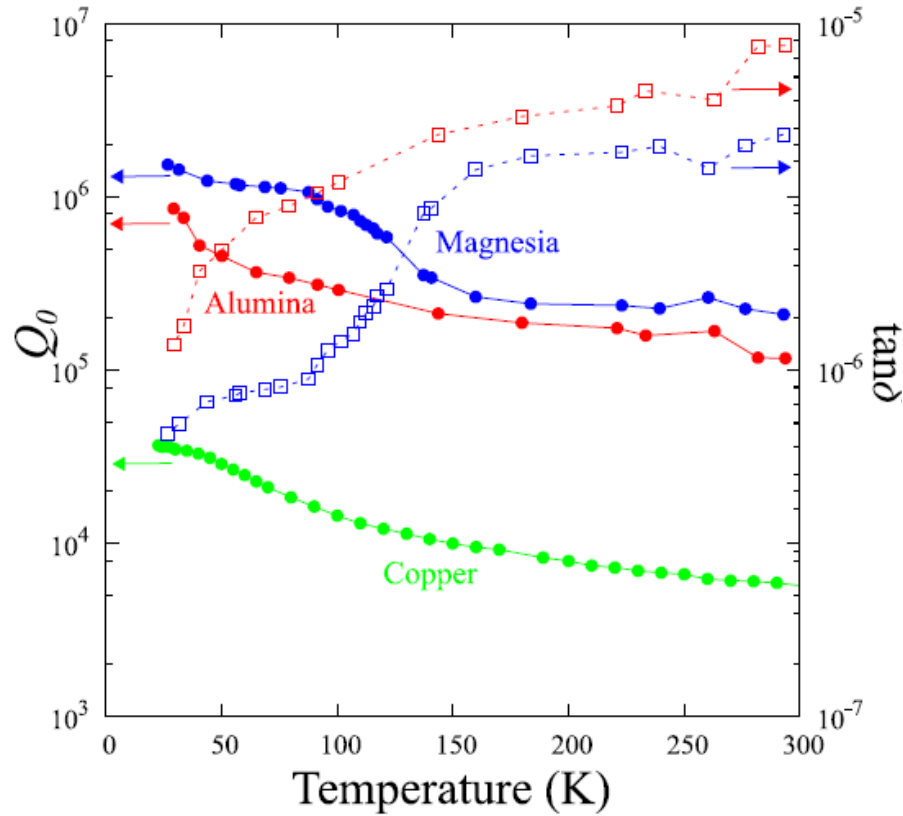
Basic cavity and accelerator parameters of cryogenic temperature operating DAA structure.

Parameters	MGO5CV1
Acc. type	standing wave type
Acc. Mode	TM ₀₂ - π mode
Number of Acc. cells	5
Frequency	5.712 GHz
Temperature	27 K
Dielectric Material	Magnesia
ϵ_r	9.64
$\tan \delta$	6.6×10^{-7}
Q_0	765,300
Z_{sh}	3.8 G Ω /m

Motivation (III)--- comparison

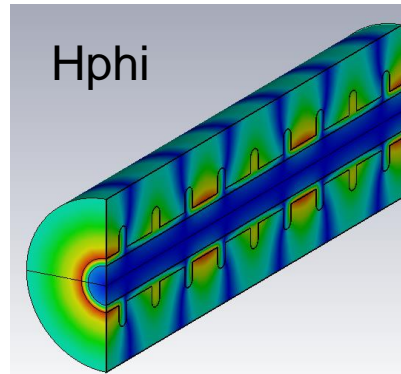
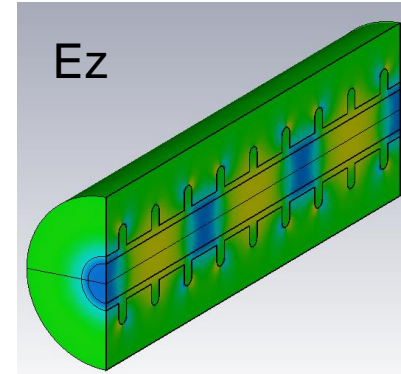
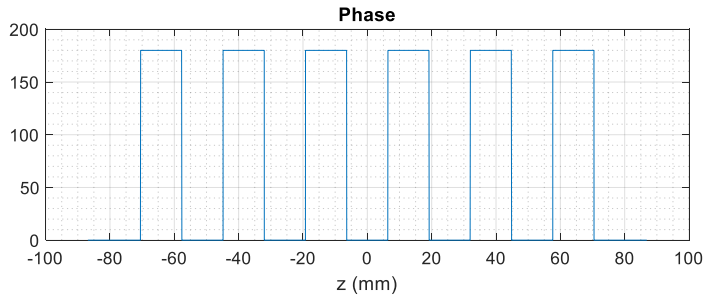
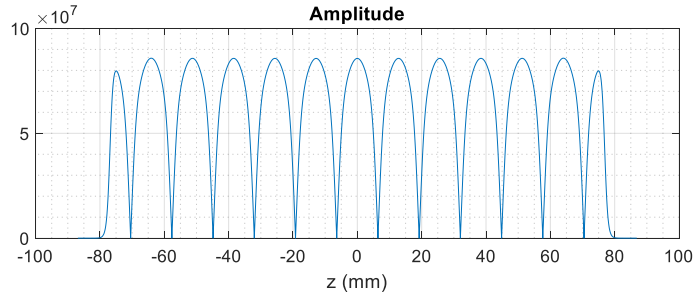
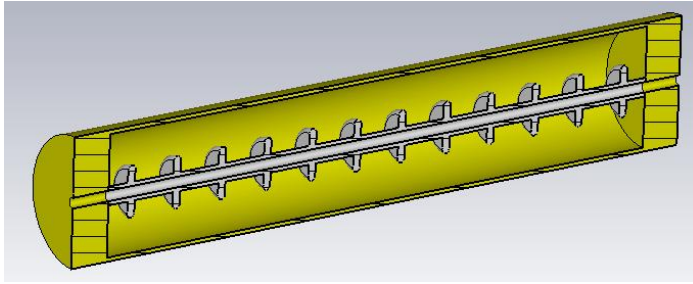
Variety of dielectric structures	Pros	Cons
 <p>dielectric vacuum</p> <p>Dielectric loaded accelerator</p>	<ul style="list-style-type: none"> - Most developed structure - Simple fabrication - Low surface fields 	<ul style="list-style-type: none"> - Moderate $r/Q \sim 20M\Omega/m$ - Weak points: tapered matching section
 <p>Copper FIG. 1(b) Dielectric Material End cell Regular cell (a)</p> <p>Dielectric assisted accelerator</p>	<ul style="list-style-type: none"> - Very high shunt impedance $\sim 620M\Omega/m$ - Prototype fabricated 	<ul style="list-style-type: none"> - Operated in TM_{02} mode; vulnerable to TM_{01} mode excitation. - Very complicated in fabrication; Current prototype is clamped together, and may not sustain high gradient - Weak points: high surface fields at joint between copper and dielectric
 <p>Dielectric disk accelerator</p>	<ul style="list-style-type: none"> - High shunt impedance $\sim 120M\Omega/m$ - TM_{01} mode operation - Easy tuning of each cell possible - Operation in different modes same as conventional copper structures (TW w different phase advance, SW) - Cryogenic shunt impedance $\sim 550M\Omega/m$ 	<ul style="list-style-type: none"> - Many pcs needed - Connection to copper is challenging
 <p>Vacuum Dielectric</p> <p>Dielectric corrugated accelerator</p>	<ul style="list-style-type: none"> - Moderate shunt impedance $\sim 80M\Omega/m$ - Feasibility of single piece fabrication - TM_{01} mode operation - Cryogenic shunt impedance $\sim 550M\Omega/m$ 	<ul style="list-style-type: none"> - Mechanical support and cooling are only at the ends - Necessary for support and cooling end walls reduce shunt impedance - Not many parameters to improve shunt impedance

Dielectric Materials in Cold



Ref.: Daisuke Satoh, *et al*, *Nucl. Inst. and Meth. Phys. Res. B* 459 (2019) 148–152.

Example 1: Cryogenic Dielectric Corrugated Accelerator (I)

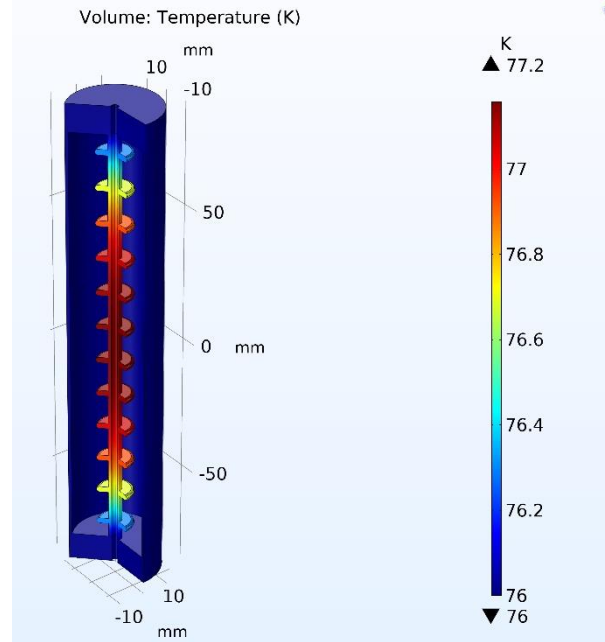


Example 1: Cryogenic Dielectric Corrugated Accelerator (II)

Q	$\tan(\delta)$	σ_{copper} (S/m)	Q	r/Q (k Ω /m)	r (M Ω /m)
77 K	3e-6	3.0e8	1.11e5	4.91	547.41
300 K	1e-4	5.8e7	1.75e4	4.91	86.06

Note: Other major simulation parameters: $f=11.7$ GHz, beam aperture $2a=2.6$ mm, TM_{01} π -mode standing wave, dielectric constant=9.8.

The thermal simulation of the X-band DCA prototype under 100 MV/m of gradient and 28 W of heat load (low duty factor at AWA).



thermal conductivity of alumina
@ 77 K = 100 W/(m \cdot K)

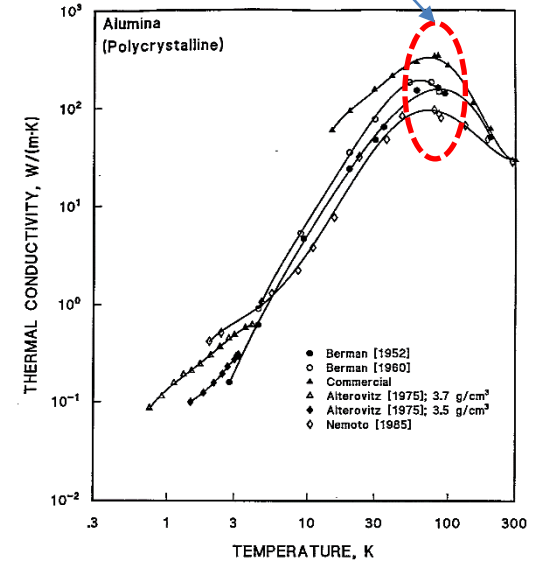
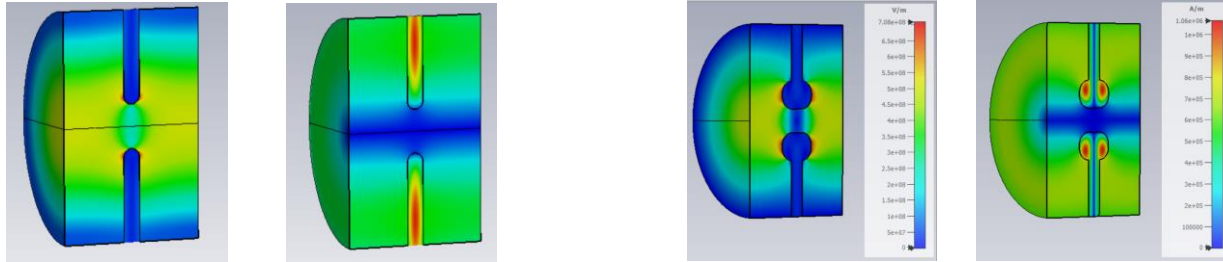


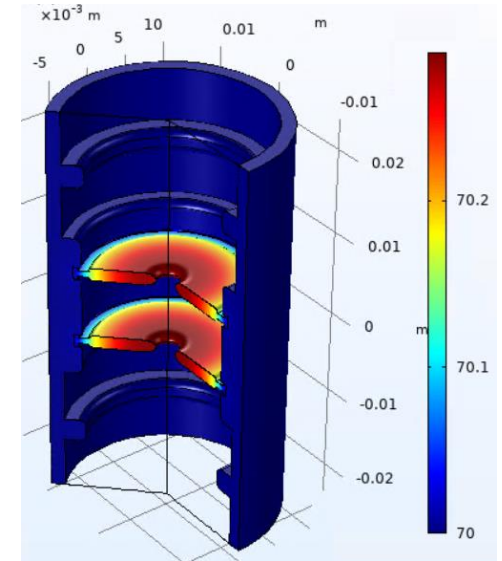
Figure 2.4.2. Thermal conductivity of polycrystalline Al_2O_3 vs. temperature. Data from Berman [1952], Berman et al. [1960], Alterovitz et al. [1975], Nemoto et al. [1985], and Touloukian et al. [1970; citations therein].

Example 2: Cryogenic Dielectric Disk Accelerator



Structure	Temp, K	aperture	epsilon	Rsh, MΩ/m
DDA	300	4	50	165
DDA	300	2.6	50	181
DDA	77	4	50	423
DDA	77	2.6	50	463
DDA 2mm nose, E _{pk} =2.5 (same as SLAC)	77	2.6	50	550
DDA 3mm nose, E _{pk} =5	77	2.6	50	706

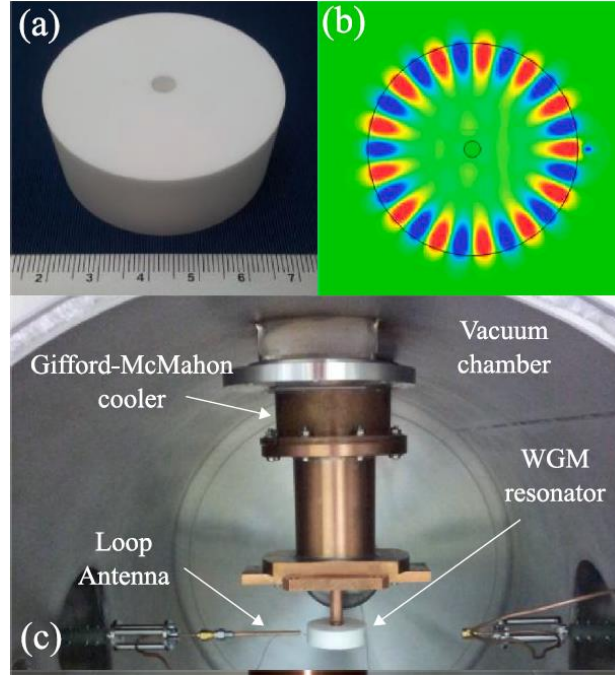
Note: Room temperature copper conductivity 5.8E7 S/m, cryogenic conductivity is 3E7 S/m;
Dielectric loss at room temperature is 1E-4, at cryogenic temperatures is 3E-6.



The thermal simulation of the X-band DCA prototype under 100 MV/m of gradient and 28 W of heat load.

Summary and Next

- Dielectric accelerator in Cryogenic temperature shows surprisingly high shunt impedance.
- Challenges remains as conventional dielectric accelerators, i.e. breakdowns due to variety of micro gaps.
- Worth to explore. The first step is to characterize different dielectric materials at low temperature.



Ref.: Daisuke Satoh, *et al*, *Nucl. Inst. and Meth. Phys. Res. B* 459 (2019) 148–152.

